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<u>PATENT</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ipplicant: Hou, Chien-Chou; et al.) Examiner: Deo, Duy Vu Nguyen

Serial No.: 10/600,377) Art Unit: 1765

Filed: June 20, 2003) Our Ref: B-5130 621033-6

For: "METHOD OF ETCHING UNIFORM) Date: April 11, 2006

SILICON LAYER")
) Re: Response

RESPONSE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is in reply to the non-final Office Action mailed on January 11, 2006, a response to which is due no later than

April 11, 2006.

Please consider the following remarks. All remarks herein are made without prejudice

Remarks/Arguments begin on Page 2 of this Response.